



2811  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Satya et al.

Attorney Docket No.: KLA1P016F/P642

Application No.: 09/648,095

Examiner: P. Cao

Filed: August 25, 2000

Group: 2811

Title: CHEMICAL MECHANICAL POLISHING  
TEST STRUCTURES AND METHODS FOR  
INSPECTING THE SAME

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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Washington, DC 20231 on January 27, 2003.

Signed:

Natalie Morgan

AMENDMENT TRANSMITTAL

Commissioner for Patents  
Washington, DC 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	9	MINUS	53	01	x 9 =	x 18 = 0
Independent Claims	3	MINUS	8	00	x 42 =	x 84 = 0
Multiple Dependent Claim Present and Fee Not Previously Paid					\$140.00	\$280.00
Total					\$	\$0



Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.



Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. KLA1P016F).

Respectfully submitted,  
BEYER WEAVER & THOMAS, LLP

  
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